

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q83944

Hiroto OHTAKE, et al.

Application No.: 10/509,898

Group Art Unit: 2818

Confirmation No.: 2975

Examiner: Hoang Quan Tran HO

Filed: October 1, 2004

For: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicants hereby petition for an extension of time of one (1) month, extending the time for responding to the Office Action of April 1, 2008 to July 1, 2008.

The USPTO is directed and authorized to charge Deposit Account No. 19-4880 for the statutory fee of \$120.00 via the EFS Web Payment Screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

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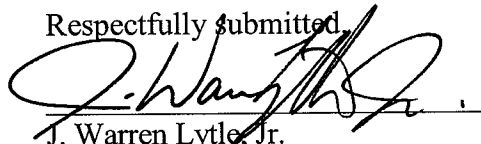
WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: August 1, 2008

Respectfully submitted,



J. Warren Lytle, Jr.

Registration No. 39,283